

FORM PTO-1449				Atty. Docket No. XA-9612		Appln. No.	
LIST OF DOCUMENTS CITED BY APPLICANT				Applicant Hiroshi INAGAWA et al.			
				Filing Date HEREWITH		Group	
U.S. PATENT DOCUMENTS							
Examiner Initial		Document Number	Date	Name	Class	Sub-class	Filing Date
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
FOREIGN PATENT DOCUMENTS							
Examiner Initial		Document Number	Date	Country	Class	Sub-class	Translation
<i>DS</i>	AJ	8-23092	1/23/96	JAPAN			Abstract
	AK	2000-277531	10/6/00	JAPAN			Abstract
	AL	9-246550	9/19/97	JAPAN			Abstract
	AM						
	AN						
	AO						
OTHER (including author, title, date, pertinent pages, etc.)							
<i>DS</i>	AP	Semiconductor Handbook, 1981, pp. 429-430.					
	AQ						
	AR						
Examiner <i>DS</i>				Date Considered <i>10/18/03</i>			
EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.							

10/04/07
 10/16/02
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